

Evaluation of Perovskite Photo-sensors with Electron-beam Evaporated Titanium Dioxide Films

M. F. Hossain,^{1,2} I. Hirano,¹ S. Naka,¹ and ^oH. Okada¹

Univ. of Toyama¹, Rajshahi University of Engineering & Technology²

E-mail: okada@eng.u-toyama.ac.jp

Organic electronic devices, such as an organic light emitting diodes (OLEDs), an organic thin-film transistors (OTFTs), an organic sensing devices and an organic solar cells (OSCs) are widely studied. Especially in OSCs, one of the most interesting topics is an organic-inorganic hybrid perovskite solar cell (PeSC) due to their excellent photoelectric conversion efficiency (PCE) along with their low material costs, and its recorded power conversion efficiency. In this situation, we have studied an electron beam evaporation (EBE) of titanium dioxide (TiO₂) layer for the electron-transport layer for the PeSC.¹⁻³ In this time, we have investigated the preliminary evaluation of organic-related perovskite photo-sensors (PePS) by applying reverse-biased voltage to collect the photo-generated carrier for light sensing applications.

Fabrication of the thin film, evaluation of a physical nature of the TiO₂ thin film, device fabrication, and measurement setup are virtually identical to that of our previous PeSC experiment.⁴ The EBE of TiO₂ with thickness of 300 nm was carried out. Then, the TiO₂ thin films were annealed with different temperatures of 150–500°C for 1 h. The perovskite layer was prepared by the two-step method using precursor solutions of PbI₂ in anhydrous N,N-dimethylformamide and methyl-ammonium iodide (MAI) in ethanol. Then, the substrate was heated with 100°C for 10 min. And then, 2,2,7,7-tetrakis (N,N-di-p-methoxyphenylamine)-9,9-spirobifluorene (Spiro-OMeTAD) solution was prepared and spin coating process was carried out. Finally, a 50 nm thick gold metal was evaporated with an evaporation rate of 1.0 Å/s.

During annealing process, the ITO sheet resistance is increased from 11.1 to 78.9 Ω/□. And the grain-cluster size is increased between 17.2 and 37.1 nm with the temperature between 150 and 500°C, respectively. From an absorption measurements, the band gap of the TiO₂ film decreases from 3.31 to 3.10 eV with the increase of annealing temperature from RT to 500°C, respectively.

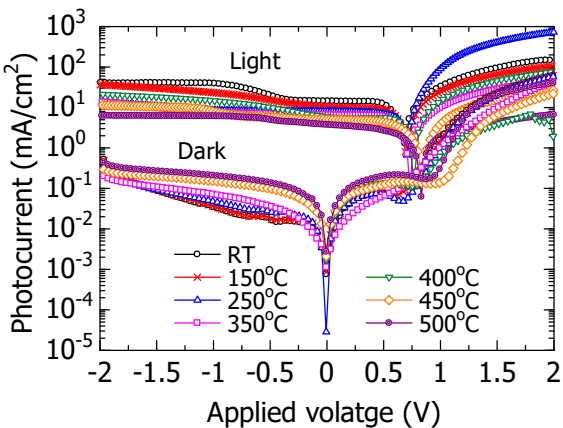


Fig. 1 Photo-sensing characteristics with different temperature of TiO₂ annealing conditions.

Table I. Photo-sensing characteristics with TiO₂ thin films at different annealing temperatures.

Annealing temperature (°C)	I _{dark} (mA/cm ²)	I _{photo} (mA/cm ²)	I _{photo} /I _{dark}
RT	3.47×10 ⁻²	39	1.12×10 ³
150	3.61×10 ⁻²	23.3	6.45×10 ²
250	4.76×10 ⁻²	8.59	1.80×10 ²
350	7.10×10 ⁻²	7.37	1.04×10 ²
400	0.174	14.7	84.5
450	0.153	7.94	51.9
500	0.209	6.11	29.2

The photo-sensing characteristics with different temperature of TiO₂ annealing conditions are shown in Fig. 1. Measured PePS characteristics are shown in Table I. A ratio of photo- and dark-current was 1.1×10³ for the PePS without annealing condition. This current ratio is the best value and gradually decreased with increase in the annealing temperature because of the decrease of photocurrent and increase of dark current. This phenomenon can be explained due to the generation current in the depletion region by⁴ $J_{gen}=qn_iW/\tau_e$, where, W is the depletion-layer width, τ_e is the effective lifetime, q is the unit charge, and n_i is the intrinsic carrier concentration. It is assumed that primary difference of the PePS characteristics with different annealing temperature is arises from the interfacial defects at TiO₂/perovskite layers and TiO₂ thin film itself, where, traps and some crystal defects induce the generation current. As a result, dark current of the PePS was increased.

Acknowledgments Prof. Md. Faruk Hossain would like to thank the Japanese Society for Promotion of Science (JSPS) for the fellowship and the financial assistance (MEXT/JSPS KAKENHI Grant Number: JP16F16372).

1) D. M. -Rojas et al., Progr. Photovoltaics **21**, 393 (2013)., 2) H. C. Weerasinghe et al., J. Photochem. Photobiol. A **213**, 30 (2010), 3) M. F. Hossain et al., J. Photochemistry & Photobiology A: Chemistry **360**, 109 (2018)., 4) S. M. Sze, Physics of Semiconductor Devices, John Wiley & Sons, New York, 644 (1981).